



PATENT  
Attorney Docket No.: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For: **METHOD OF PLASMA  
ENHANCED CHEMICAL  
VAPOR DEPOSITION OF  
DIAMOND USING  
METHANOL-BASED  
SOLUTIONS**

) Art Unit: 1762

) Examiner: Stouffer, Kelly M.

) **REQUEST FOR A ONE MONTH  
EXTENSION OF TIME**

) 162 North Wolfe Road  
) Sunnyvale, CA 94086  
) (408)530-9700

) Customer Number 28960

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby petition for a three (3) month extension of time to answer the outstanding Office Action mailed November 22, 2006 regarding the above-identified patent application. Please find a check enclosed in the amount of \$905.00 (\$395.00 to cover the request for continued examination, plus \$510.00 to cover the three month extension of time filing fee).

Respectfully submitted,  
HAVERSTOCK & OWENS LLP

Dated: May 11, 2007

By: Jonathan O. Owens  
Jonathan O. Owens  
Reg. No.: 37,902

Attorneys for Applicant  
05/16/2007 1625HH1 00000017 10772740

02 FC:2253

510.00 OP

**CERTIFICATE OF MAILING (37 CFR § 1.8(a))**

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.

Date: 5/11/07 Miriam Keener